


U.S. Department of Commerce, Patent and Trademark Office <div style="position: relative; height: 100px;"> <div style="position: absolute; top: 0; left: 0; width: 100%; text-align: center;"> LIST OF RELEVANT ART CITED BY APPLICANT (Use several sheets if necessary) </div> <div style="position: absolute; top: 0; left: 0; width: 100%; text-align: center;">  </div> </div>				Docket No.: 7956/DISPLAY/AHRDWR/RKK		Serial No.: 10/782,503	
Applicants: Shinichi Kurita, et al							
Filing Date: February 19, 2004						Group: 2829	

U.S. Patent Documents							
*Examiner Initial	Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate	
JN	US-1	6,158,946	12/12/00	Miyashita			
JN	US-2	2002/0051697 A1	05/02/02	Ko et al.			
JN	US-3	6,499,367 B1	12/31/02	Saeki			
	US-4						
	US-5						
	US-6						
	US-7						
	US-8						
	US-9						
	US-10						
	US-11						

Foreign Patent Documents							Translation	
	Document Number	Date	Country	Class	Subclass	Yes	No	
JN	F-1	JP 06089845	03/29/94	Japan		X		
JN	F-2	JP 08313815	11/29/96	Japan		X		
JN	F-3	JP 2002308420	10/23/02	Japan		X		
JN	F-4	JP 09152569	06/10/97	Japan		X		
JN	F-5	JP 09090308	04/04/97	Japan		X		
JN	F-6	JP 06204321	07/22/94	Japan		X		

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)	
OT-1	
OT-2	
OT-3	

Examiner <i>Vianey Nguyen</i>	Date Considered 4/13/06
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.